



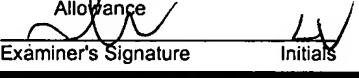
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APPLICANTS Toyokazu Sakata, Tokyo, JAPAN;					
** CONTINUING DATA ***** <i>NONE</i> ✓					
** FOREIGN APPLICATIONS ***** <i>YES</i> ✓ JAPAN 2003-149057 05/27/2003					
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 03/11/2004					
Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY JAPAN	SHEETS DRAWING 3	TOTAL CLAIMS 15	INDEPENDENT CLAIMS 3
VERIFIED AND ACKNOWLEDGED Examiner's Signature  Initials 					
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TITLE Etching method and semiconductor device fabricating method					
FILING FEE RECEIVED 770	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue)			